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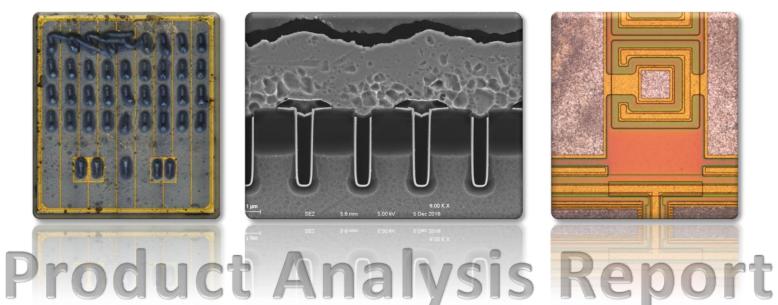


Wechat



TCS IGBT Die

Temperature Sensor and Current Sensor IGBT Die



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